

PATENT APPLICATION  
Docket No.: 4591-366  
Client Ref. No.: IC12242-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Jeong-Min CHOI, et al.

Serial No.:	10/750,983	Examiner:	Erdem, Fazli
Filed:	January 2, 2004	Group Art Unit:	2826
Confirmation No.:	5470		
For:	SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND METHOD OF FABRICATING THE SAME		

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Responsive to the Office Action, Paper No. 11122006, dated November 17, 2006, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

An **Appendix** including a certified English translation of the priority document is attached following page 7 of this paper.